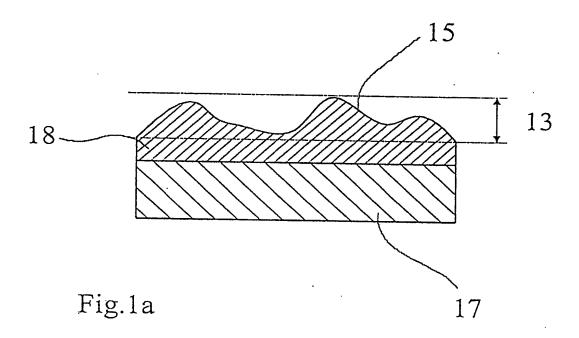
Inventor: Joachim MAI et al. Customer No.: 000028107

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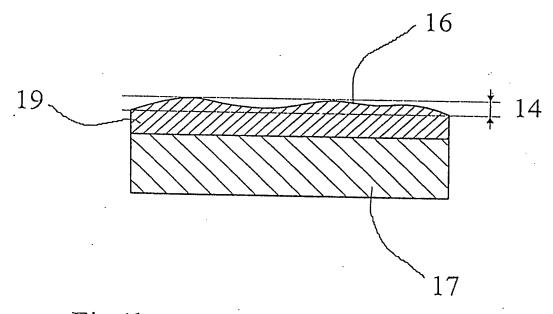


Fig.1b

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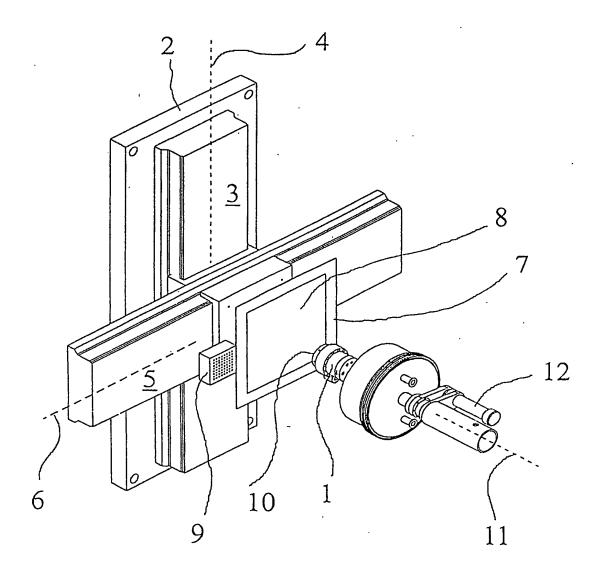


Fig.2